Hourly Use Rates for the Material Research Laboratory Facilities

Rates for researchers employed by the University of Illinois at Urbana-Champaign, other public sector employers, and companies located in the EnterpriseWorks Incubator at the University of Illinois Research Park.

If you have any questions, please contact the MRL Business Office at 217-333-1372.

The rates listed below do not include overhead fees, such as Facilities and Administration, which will be added depending on your funding instrument or agreement.

| | Center for Excellence in Soft Materials | | |
|------------------------------|---|----------|------------------|
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Malvern Zetasizer | Particle Size and Zeta Potential Measurements | \$13 | \$5 |
| Metrohm 915 KF Ti-Touch | Volumetric Karl Fischer Titration | \$13 | \$5 |
| Metrohm 917 Coulometer | Coulometric Karl Fischer Titration | \$12 | \$5 |
| Nanoparticle tracking NS300 | Nanoparticle tracking analysis | \$20 | \$6 |
| Novocontrol C47 Analyzer | Dielectric, Conductivity and Impedance Spectrometer | \$19 | \$5 |
| Q50-TGA | Thermogravimetric Analysis | \$21 | \$6 |
| Q800-DMA | Dynamic Mechanical Analysis | \$19 | \$5 |
| Shimadzu DTA-50 | Differential Thermal Analysis | \$17 | \$5 |
| TA DHR-3 Rheometer | Discovery Hybrid Rheometer | \$20 | \$6 |
| TA DSC 2500 | Differential Scanning Calorimetry | \$21 | \$6 |
| Tosoh EcoSEC GPC | Gel Permeation Chromatography | \$16 | \$5 |
| | Laser and Spectroscopy Facility | | |
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Agilent CARY 5000 | Spectrophotometry | \$18 | \$5 |
| Custom Experiment | Custom Laser Experiments | \$16 | \$5 |
| Gaertner Ellipsometer | Ellipsometry | \$18 | \$5 |
| Horiba Xplora-Nano TERS-TEPL | Tip Enhanced Raman and PL Spectroscopy | \$18 | \$5 |
| Inspire OPO Laser | Time-Domain Thermoreflectance, Custom Laser Experiments | \$15 | \$5 |
| Keyence VK-X1000 | Optical Profiler | \$26 | \$6 |
| Montana Cryo Station | Closed He Cycle Optical Cryo Station | \$5 | \$4 |
| Nanophoton Raman 11 | Raman Spectroscopy/Microscopy | \$22 | \$6 |
| Neaspec IR AFM | Tip Enhanced Infrared Spectroscopy | \$18 | \$5 |
| Newport Solar Simulator | Custom Experiments | \$15 | \$5 |
| Nicolet Nexus 670 FTIR | Fourier Transform Infrared Spectroscopy | \$17 | \$5 |
| OL 750 Spectroradiometer | Spectroradiometry | \$15 | \$5 |
| Oxford Cryo Station | Closed He Cycle Cryo Station | \$5 | \$4 |
| Photoluminescence | Photoluminescence/Fluorescence | \$21 | \$6 |
| Quantum Diamond Microscope | N-vacancy magnetometry | \$15 | \$5 |
| Rame-Hart Contact Angle | Contact Angle Goniometry | \$16 | \$5 |
| SLM ISS Fluorometer | Photoluminescence/Fluorescence | \$15 | \$5 |
| Thermo-Nicolet Is-50 FTIR | Fourier-Transform IR spectroscopy | \$15 | \$5 |
| Time Resolved PL | Photoluminescence/Fluorescence | \$20 | \$6 |
| Tsunami Ti-Sapphire Laser | Time-Domain Thermoreflectance | \$15 | \$5 |
| Tsunami Ti-Sapphire Laser 2 | Time-Domain Thermoreflectance | \$15 | \$5 |
| Two Photon Microscopy | Optical Microscopy | \$15 | \$5 |
| Varian Cary5G UV-VIS-NIR | Spectrophotometry | \$18 | \$5 |
| Witec Alpha NSOM | Near Field Scanning Optical Microscopy | \$16 | \$5 |
| Woollam VAS Ellipsometer | Spectroscopic Ellipsometry | \$21 | \$6 |

| Micro & Nano-Fabrication Facility | | | |
|-----------------------------------|--|----------|------------------|
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| ADT 7122 Wafer Dicer | Automated sample dicer | \$22 | \$62 |
| AJA Sputter Coater | Sputter Coater | \$25 | \$65 |
| AJA Sputter Coater 2 | Sputter Coater | \$26 | \$66 |
| AJA Sputter Coater 3 | Sputter Coater | \$27 | \$67 |
| AJA Sputter Coater 4 | Sputter Coater | \$27 | \$67 |
| Atomic Layer Deposition | Atomic Layer Deposition | \$26 | \$66 |
| Atomic Layer Deposition 2 | Atomic Layer Deposition | \$26 | \$66 |
| Ball Bonder | Ball Bonder | \$19 | \$59 |
| Cleanroom | Cleanroom | \$18 | \$58 |
| CM Furnace | Furnace | \$8 | \$48 |
| Desert Cryo Probe Station | Probe Station | \$23 | \$63 |
| E-beam Evaporator 1 | Electron Beam Evaporation | \$26 | \$66 |
| E-beam Evaporator 2 | Electron Beam Evaporation | \$26 | \$66 |
| E-beam Evaporator 4 | Electron Beam Evaporation | \$27 | \$67 |
| Graphene Furnace | Furnace for the growth of carbon nanotubes and graphene layers | \$7 | \$47 |
| Harrick Plasma Cleaner | Plasma Cleaner | \$19 | \$59 |
| Heidelberg Maskless Writer | Maskless wafer aligner | \$26 | \$66 |
| Hydrogen Vacuum Furnace | Furnace | \$11 | \$51 |
| Ion Mill Evaporator | Ion Mill & Thermal Evaporator | \$30 | \$70 |
| Jandel 4 Point Probe | Four point probe | \$19 | \$59 |
| Lindberg 3 Zone Furnace - 2 inch | Furnace | \$10 | \$50 |
| March RIE | Reactive Ion Etcher for polymer samples | \$22 | \$62 |
| March RIE2 | Reactive Ion Etcher for polymer samples | \$22 | \$62 |
| Mitutoyo Microscope | Optical Microscope | \$22 | \$62 |
| MTI Furnace - 2 inch | Furnace | \$9 | \$49 |
| Nanomaster RIE | Reactive Ion Etcher for polymer samples | \$23 | \$62 |
| Nanoscribe 3D Printer | Laser lithography 3D printer | \$24 | \$64 |
| Olympus Microscope | Optical Microscope | \$20 | \$60 |
| Oven-Vacuum | Oven | \$4 | \$44 |
| Parylene Coater | Parylene Deposition - SCS Labcoter 2 | \$24 | \$64 |
| PECVD 2 | Plasma Enhanced Chemical Vapor Deposition | \$22 | \$62 |
| Probe Station | Probe Station | \$21 | \$61 |
| Raith EBPG5150 | Electron Beam Lithography | \$67 | \$107 |
| Raith e-Line | Electron Beam Lithography | \$52 | \$92 |
| RaithPrep | Cleanroom | \$18 | \$58 |
| Reactor Vacuum Furnace | Furnace | \$6 | \$46 |
| RIE | Reactive Ion Etcher | \$24 | \$64 |
| RTA Furnace | Furnace | \$12 | \$52 |
| Suss MJB3 - Deep UV | Mask Aligner - Deep UV | \$0 | \$53 |
| Suss MJB3 - Mask Aligner | Mask Aligner | \$0 | \$53 |
| Suss MJB4 - Mask Aligner | Mask Aligner | \$0 | \$53 |
| Thermal Evaporator | Thermal Evaporation | \$25 | \$65 |
| Tube Furnace - 6 inch | Furnace | \$7 | \$4 |
| Wedge Bonder | Wedge Bonder | \$20 | \$60 |
| Westbond Bonder | Wire Bonder | \$24 | \$64 |
| | adium incurs an additional charge of \$4 per every 10 nm deposited or fraction | | ΨŪ |

| | Microscopy-Scanning Probe | | |
|-------------------------------|--|----------------------|------------------|
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Asylum AFM 1 | Atomic Force Microscopy | \$20 | \$60 |
| Asylum AFM 2 | Atomic Force Microscopy | \$20 | \$60 |
| Asylum Cypher AFM | Atomic Force Microscopy/High Resolution | \$23 | \$63 |
| Asylum MFP-3D-Bio AFM | Atomic Force Microscopy for biological materials | \$22 | \$62 |
| Dektak 3030 | Surface Profilometry | \$16 | \$56 |
| Hysitron Tip | Nanoindentation | \$10 | \$50 |
| Hysitron TriboIndenter | Nanoindentation | \$24 | \$64 |
| Leitz Microhardness | Microhardness tester | \$5 | \$45 |
| Molecular Vista PiFM-Raman | Photo-induced Force Microscopy | \$21 | \$61 |
| Piuma Nanoindenter | Nanoindentation | \$21 | \$61 |
| | Microscopy-Scanning Electron | | |
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| | | | |
| HELIOS 600i FIB | Scanning Electron/Focused Ion Beam Microscopy | \$44 | \$84 |
| Hitachi S4800 SEM | Scanning Electron Microscopy/High Resolution | \$31 | \$71 |
| JEOL 6060LV SEM | Scanning Electron Microscopy/Low Vacuum | \$27 | \$67 |
| JEOL 7000F SEM | Scanning Electron Microscopy/Analytical SEM | \$31 | \$71 |
| Scios 2 FIB | Scanning Electron/Focused Ion Beam Microscopy | \$46 | \$86 |
| Thermo Axia ChemSEM | Scanning Electron Microscopy/Low Vacuum | \$30 | \$70 |
| | Microscopy-Transmission Electron | | |
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Hitachi 9500 | Transmission Electron Microscopy | \$50 | \$90 |
| JEOL 1400 TEM | Transmission Electron Microscopy | \$35 | \$75 |
| JEOL 2010 LaB6 | Transmission Electron Microscopy | \$34 | \$74 |
| JEOL 2100 Cryo TEM | Transmission Electron Microscopy | \$36 | \$76 |
| Thermo Talos F200X TEM-STEM | Transmission Electron Microscopy | \$57 | \$97 |
| Thermo Themis Z TEM-STEM | (Scanning) Transmission Electron Microscopy/Analytical | \$67 | \$107 |
| ThermoFisher Glacios Cryo-TEM | Cryo-TEM for SPA, tomography and micro-ED | \$64 | \$104 |
| | er Glacios Cryo-TEM that are longer than 4 hours will be charged at \$40/h | nr after the 4th hou | |
| | Support Equipment | | |
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Allied Multiprep | TEM sample preparation | \$7 | \$47 |
| Carbon Rod Coater | SEM Carbon Coater | \$10 | \$50 |
| Carbon String Coater | SEM Carbon Coater | \$10 | \$50 |
| FEI Vitrobot | Cryo-plunge for TEM sample preparation | \$14 | \$54 |
| FEI Mark IV Vitrobot | Cryo-plunge for TEM sample preparation | \$16 | \$56 |
| Gatan CryoPIPS | Cryo-Ion Miller for TEM sample preparation | \$10 | \$50 |
| Gatan PECS II | Ion Miller for SEM sample preparation | \$21 | \$61 |
| Leica EM UC6 Microtome | Microtome for TEM sample preparation | \$18 | \$58 |
| PicoIndenter | Nanoindentation | \$16 | \$56 |
| Princeton WS-25 Wire Saw | Wire Saw - High Precision | \$10 | \$47 |
| SEM Sputter Coater 1 | SEM Sputter Coater | \$11 | \$51 |
| SEM Sputter Coater 2 | SEM Sputter Coater | \$11 | \$5: |
| Tergeo EM Plasma Cleaner | Plasma Cleaner for TEM sample preparation | \$11 | \$5: |
| Vibratory Polisher 1 | Vibratory Polisher | \$11 | \$5. |
| | | 54 | 544 |

| | Physical Property Measurement | | |
|---------------------------------|--|----------|------------------|
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| QD MPMS3 SQUID | Magnetic Property Measurment System | \$7 | \$47 |
| QD MPMS3 SQUID B | Magnetic Property Measurment System | \$7 | \$47 |
| QD Opticool | Optical Cryostat | \$6 | \$46 |
| QD PPMS | Physical Property Measurment System | \$9 | \$49 |
| QD PPMS B | Physical Property Measurment System | \$9 | \$49 |
| | Surface Analysis | | |
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Cameca LEAP 5000XS APT | Local Electrode Atom Probe Tomography | \$61 | \$101 |
| KRATOS AXIS XPS | X-Ray Photoelectron Spectroscopy/Imaging XPS | \$32 | \$72 |
| Kratos Supra XPS | X-Ray Photoelectron Spectroscopy / Imaging and Depth Profiling | \$40 | \$80 |
| NEC Pelletron | Ion Accelerator/Rutherford Backscattering Spectroscopy | \$47 | \$87 |
| PEI Trift-III TOF-SIMS | Secondary Ion Mass Spectroscopy/Time-of-Flight | \$28 | \$68 |
| | X-ray Analysis | | |
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Bruker D8 Advance | X-ray diffraction with high-temperature stage | \$23 | \$63 |
| Dexco Laue | X-ray Diffraction/Laue | \$16 | \$56 |
| PANalytical XPert | High-resolution X-ray diffraction and reflectometry | \$15 | \$55 |
| SAXS | X-Ray scattering: SAXS, WAXS, GI-SAXS and GI-WAXS | \$14 | \$54 |
| Shimadzu EDXRF | X-Ray Fluorescence | \$23 | \$63 |
| Siemens-Bruker D5000 XRD | X-Ray Diffraction/Powder | \$13 | \$53 |
| | MRL Carver BioMaker Lab | | |
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Autoclave | Sterilization | \$12 | \$52 |
| Biosafety Cabinet-Room 0014 | Biosafety Cabinet | \$0 | \$40 |
| Biosafety Cabinet-Room 0015 | Biosafety Cabinet | \$0 | \$40 |
| CarverBioMakerLab | Lab suite access for sample prep and imaging | \$1 | \$41 |
| Cellink BioX 3D bioplotter | 3D printing (tissue, cell, etc. using bioinks) | \$20 | \$60 |
| CO ₂ incubator | Cell culture | \$1 | \$41 |
| Fisher Gravity Incubator | Gravity Incubator | \$1 | \$41 |
| Fisher Isotemp Incubator | Isotemperature Incubator | \$1 | \$41 |
| GESIM nanoplotter | 3D printing for cell spotting | \$20 | \$60 |
| Microfluidics flow control | Optional flow control for the printer | \$10 | \$50 |
| Microfluidics printer | 3D printing of microfluidics structures | \$20 | \$60 |
| MTI electrospinner | 3D printing of nanofibers | \$15 | \$55 |
| Nanodrop | DNA, RNA or protein concentration measurement | \$10 | \$50 |
| NUAIRE CO2 Incubator | CO2 incubator | \$1 | \$41 |
| Optima LE-80 Ultracentrifuge | Ultracentrifuge | \$15 | \$55 |
| Polarized Optical Microscope | Optical Microscopy | \$15 | \$55 |
| Thermo CO2 incubator-bottom | CO2 incubator | \$1 | \$41 |
| Thermo CO2 incubator-top | CO2 incubator | \$1 | \$41 |
| Zeiss Axio-Inverted Microscope | Fluorescence Microscopy | \$13 | \$53 |
| Zeiss LIVE7 Confocal Microscope | Fluorescence Confocal Microscopy | \$15 | \$55 |

| | Biomaterial Services Lab | | |
|-----------------------------------|---|---------------------|--------------------------------------|
| Instrument | Tashainua | Self Use (\$/hr) | Staff Assisted & Training (\$/hr) |
| Instrument | Technique | | |
| Bio-BioSEM | Bio SEM Prep | N/A | \$59 |
| Bio-Embed | Embedding & Deparaffinization | N/A | \$60 |
| Bio-EMScopeVM | EM Scope Tech Time | N/A | \$80 |
| Bio-LMSect | Trim & LM Sectioning | N/A | \$54 |
| Bio-NegDevelop | Negative Development | N/A | \$75 |
| Bio-NegScan | Negative Scanning | N/A | \$50 |
| Bio-NegStain | Negative Staining & Grids | N/A | \$53 |
| Bio-OptoMicro | Optical Camera Tech Time | N/A | \$54 |
| Bio-TEMSect | Trim & TEM Sectioning | N/A | \$70 |
| Reichart Ultracut | Microtome for TEM sample preparation | \$20 | \$60 |
| AMTEL | -Advanced Materials Testing and Evaluation Laboratory | Y | |
| | | Self Use | Staff Assisted & |
| Instrument | Technique | (\$/hr) | Training (\$/hr) |
| Servo-hydraulic 1* | Uniaxial testing | \$50 | \$90 |
| Servo-hydraulic 2* | Uniaxial testing | \$50 | \$90 |
| Servo-hydraulic 3* | Uniaxial testing | \$50 | \$90 |
| Servo-hydraulic 4* | Uniaxial testing | \$50 | \$90 |
| Servo-hydraulic 5* | Uniaxial testing | \$50 | \$90 |
| Servo-hydraulic 6 (Bi-Axial)* | Bi axial testing (axial and torsion) | \$75 | \$115 |
| Electro-Mechanical 1* | Uniaxial testing | \$50 | \$90 |
| Electro-Mechanical 2* | Uniaxial testing | \$50 | \$90 |
| Electro-Mechanical 3* | Uniaxial testing | \$50 | \$90 |
| Thermo-Mechanical 1* | Uniaxial testing with combined thermal loading | \$75 | \$115 |
| Thermo-Mechanical 2* | Uniaxial testing with combined thermal loading | \$75 | \$115 |
| Thermo-Mechanical 3* | Uniaxial testing with combined thermal loading | \$75 | \$115 |
| Thermo-Mechanical 4* | Uniaxial testing with combined thermal loading | \$75 | \$115 |
| Thermo-Mechanical 5* | Uniaxial testing with combined thermal loading | \$75 | \$115 |
| Split-Hopkinson Bar* | High strain rate material testing | \$50 | \$90 |
| Creep Stand* | Temperature dependent creep testing | \$25 | \$65 |
| Rotating Bending* | Rotating bending high cycle fatigue testing | \$25 | \$65 |
| Dynamic Mechanical Analysis* | Dynamic mechanical analysis | \$50 | \$90 |
| High Speed - Thermal Camera* | High speed and/or thermal imaging | \$25 | \$65 |
| Strain - Thermal Acquisition Box* | Additional strain, thermocouple, analog input data acquisition | \$25 | \$65 |
| 3D Digital Image Correlation* | Calibration, acquisition, and/or analysis of 3D surface coordinates | \$25 | \$65 |
| Paint Booth | Speckle painting for digital image correlation sample preparation | \$3 | \$43 |
| Laser Engraver | Engraving for digital image correlation sample preparation | \$3 | \$43 |
| Sand Blasting | Sandblasting for digital image correlation sample preparation | \$3 | \$43 |
| Wet-Dry Sander 1 | Polishing for digital image correlation sample preparation | \$3 | \$43 |
| Wet-Dry Sander 2 | Polishing for digital image correlation sample preparation | \$3 | \$43 |
| Vibration Polisher | Polishing for high magnification digital image correlation sample prepara | \$3 | \$43 |
| Pico Saw | Diamond blade wafer saw for sample preparation | \$6 | \$46 |
| Ultrasonic Bath | Ultrasonic bath for sample preparation | \$6 | \$46 |
| | *Maximum charge of 2 hours per day of usage. | ΨŪ | γiυ |

| Battery Fabrication and Characterization Laboratory | | | |
|---|--|---------------------|--------------------------------------|
| Instrument | Technique | Self Use (\$/hr) | Staff Assisted & Training (\$/hr) |
| BatteryLabAccess | Access to 15+ tools for cells/pouch fabrication | \$1 | \$41 |
| Calendaring | Hot roller press | \$1 | \$41 |
| Electrochem characterization* | Potentiostat, gavanostat, electrchemical impedance | \$5 | \$45 |
| Magnetic stirrer | Stirring and mixing solutions | \$0 | \$40 |
| Mixer - Thinky | Slurry mixing | \$1 | \$41 |
| Slurry coater | Automated coater for metal foils | \$2 | \$42 |
| Vacuum Oven - Battery Lab* | Up to 150C heating under vacuum | \$2 | \$42 |
| Vigor glovebox | With sealer, die cutter, welding and crimper | \$1 | \$41 |
| | * Maximum charge of 1 hour per day of usage. | | |